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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michael J. Scaggs

Application No.: 09/733,874

Filed: December 8, 2000

For: 157 NM LASER SYSTEM AND
METHOD FOR MULTI-LAYER
SEMICONDUCTOR FAILURE
ANALYSIS

Confirmation No.: 3133

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Examiner: Jose R. Diaz

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